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### OPTICAL CHARACTERIZATION OF STABILIZED ATMOSPHERIC PRESSURE PIN TO PLATE PLASMA SOURCE

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#### ABSTRACT

DC Stabilized Discharges (DCSD) was generated in atmospheric pressure argon for a pin to plate. In this paper, discharge with a flowing argon gas into the air (plasma Source) is investigated by optical emission spectroscopy technique. The emission spectra of excited species of atomic-hydrogen, N<sub>2</sub> and Ar were observed and measured. The rotational and vibrational temperatures of the discharge were measured by comparing modelled optical emission spectra with masured spectra from the discharge by using several different vibrational bands of the 2nd positive system (SPS) of N<sub>2</sub> ( $N_2[C \ {}^3\Pi_u] \rightarrow N_2[B \ {}^3\Pi_g]$ ). The optical characteristics of the discharge shown that the DCSD was found to be non-equilibrium with rotational temperature (T<sub>r</sub>) of 1087 K and vibrational temperature (T<sub>v</sub>) of 1661 K. Boltzmann plot method has been applied to estimate the electronic excitation temperature which was found to be 1.36 eV and 1.1 eV for discharges with argon flow rates of 1.0 SLM & 0.5 SLM respectively. This finding proved the strong non-equilibrium nature of the discharge conditions of the current work.

Keywords: Atmospheric Pressure; Pin to Plate; Stabilized

#### **1. INTRODUCTION**

Over the last two decades, research on atmospheric pressure non-equilibrium plasmas has intensified, resulting in a wide range of plasma sources for a wide range of applications such as chemical conversion, medicine, chemical analysis, and disinfection., without the need for vacuum equipment. Non-thermal plasma (also known as a cold plasma or nonequilibrium plasma) are typically characterized by their translational temperature( $T_{trans}$ ) < rotational temperature ( $T_{rot}$ ) < vibrational temperature ( $T_{vib}$ ) < electron temperature ( $T_e$ ) [1-2]. In plasma-assisted materials applications, *Available at Egyptian Knowledge Bank (EKP)*  the nonequilibrium nature enables active species to interact with the sample without generating too much heat which could destroy the sample [3-5]. Non- equilibrium plasma is a future tool for the treatment of cancer, some diseases, and many medical applications [6-9].

Although non-equilibrium glow discharges at low pressure can be easily produced (usually a few hundred Volts DC), the glow discharge tends to be unstable and restricted with rising pressure: a glow-to-spark transition occurs. Special geometries, electrodes, or excitation methods should therefore be used to create

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glow discharges at atmospheric pressure [10-12].

Non-equilibrium atmospheric pressure glow discharges have to be stabilized with disparate solutions, Take, for instance, by connecting a resistor in series. For constant applied voltage, the series resistor can prevent current runaway by causing the voltage across the discharge gap to decrease with increasing current. A capacitor or inductance in series with the discharge gap can produce similar results. The latter has been shown by Aldea et al. [13], who used it to stabilize large area APGDs for material treatment applications. Atmospheric pressure glow discharges stabilized by resistive electrodes are studied by Laroussi et al. [14]. Also, water is used to generate glow discharges, as has been studied by Andre et al. [15], Lu and Laroussi [16], and Bruggeman et al. [17]. Staack et al. [18] examined DC glow and micro glow discharges between two metal electrodes. Because of the high surface-volume ratio and consequently efficient heat disposal, the micro glow discharges remain stable. Akishev and Leys groups studied how to keep high-current glow discharges stable. The transition from the glow to the spark can be postponed to bigger currents with a gas flow on the order of 10 ms<sup>-1</sup> [19, 20]. Staack et al[21], found that the ionization overheating instability leading to transition of the discharge to the contracted state, In order to prevent developing of instabilities of glow discharge in transverse gas flow the partitioned cooled cathodic blocks are used by cathodic sections in the cathodic block are separated from each other by dielectric layers.

In the current work we constructed pin to plate plasma source operating at atmospheric pressure to generate stabilized non-equilibrium plasma for material processing applications. We investigated the produced plasma using optical emission spectroscopy. The strategy of obtaining stabilized atmospheric pressure nonequilibrium plasma was to remove the produced heat the discharge region by flowing argon through the neddle electrode in addition to using a massive stainless steel cathode.

This paper is organized as follows. After this general introduction, Section 2 describes the experimental setup used for creating and analysing the pin to plate. Results and discussion is presented in section 3 while the conclusion of the work is presented in section 4.

#### 2. EXPERIMENTAL SETUP

The arrangement for creating and analysing data of stabilized discharge is depicted in figure 1 and a photograph of the discharge is shown in figure 2. We used a stainless steel needle as an anode with a 0.5 mm inner diameter. Working argon gas was fed through the needle anode, which was placed above a stainless-steel plate working as cathode with a separation distance of 3.4 mm in the open air. The gas flow rate was adjusted in the range from 0.20 to 2.0 SLM with the use of a mass flow controller (MC-2SLPM-D/5 M, Alicat Scientific), which is connected in parallel with the anode through a rubber tube and the setup's ground was connected to the cathode. A homemade DC power source was constructed and utilised to derive the discharge. This power supply is capable of derving the discharge by applying an applied voltage up to 12 kV and current 50mA. The discharge current was limited by a 100 k  $\Omega$ load resistance. The cathode plate was connected to the ground potential via a  $100\Omega$ resistor to measure the discharge current which is equal to the potential drop across the resistor divided by the resistor value. A home-made voltage probe was used to measure the discharge voltage, which was linked in parallel with the needle anode and the setup's ground.

A UV–VIS SD2000 dual fibre optic emission spectrometer from Ocean optics was used to monitor the optical emission spectroscopy (OES) at the centre of the discharge region.



**Fig. 1.** The electrical circuit that is used to generate DCSD.



Fig. 2. Photograph of DCSD.

#### 3. RESULTS AND DISCUSSION

DCSD was studied using optical emission spectroscopy at atmospheric pressure needle anode to plate cathode discharge where argon gas was flowing through the needle anode into air. All spectra were measured for emission collected from the centre of the discharge where the separation distance of the anode and the cathode was set at 3.4 mm. The emitted spectra were analysed to identify the reactive species in the discharge. Emission of some of argon atomic and ionic lines was used to define the electronic excitation temperature of DCSD using Boltzmann plot method. The rotational and vibrational temperatures  $(T_r \& Tv)$  of the  $N_2$  second positive system  $(C^3\Pi_u - B^3\Pi_g)$ transition) were evaluated by comparing the experimental observations with simulated spectra.

## **3.1. Identification of species in the discharge region**

Optical emission spectra of the discharge operated with argon flow rates of 0.5 and 1.0 SLM for discharge current of 30 mA (standard litre per minute) were analysed to identify the species that generated in the discharge region. Optical emission spectra can be divided into three regions. UV region for emission below 400 nm, visible region for emission between 400 nm to 700 nm and infrared region for emission above 700 nm.

#### a) UV Region

Emission spectra in the UV region are depicted in figures 3(a) and 3(b) for discharge of argon flow rates of 0.5 SLM & 1.0SLM respectively. The N<sub>2</sub> Second Positive System is responsible for the most powerful emissions recorded between 350 and 400 nm (N<sub>2</sub>[C  ${}^{3}\Pi_{\mu}$ ]  $\rightarrow$  N<sub>2</sub>[B <sup>3</sup> $\Pi_g$ ]) emission bands, with a prevailing emission (0,1) band head at 357.69 nm, emission (0,2) band head at 380.49 nm, emission (1,3) band head at 375.5 nm, emission (1,2) band head at 353.83 nm. In addition to few weak argon ionic lines. The N2 Second Positive System's emission (N<sub>2</sub>[C  ${}^{3}\Pi_{u}$ ]  $\rightarrow$  N<sub>2</sub>[B  ${}^{3}\Pi_{g}$ ) is attributed to the nitrogen gas of the surrounded air that is entrained to the discharge region[28]. From figures 3(a) & 3(b) the N<sub>2</sub> Second Positive Emission Intensity for the discharge of argon flow rate of 1.0SLM is weaker than that of the argon flow rate of 0.5 SLM case. This might be attributed to the smaller density of nitrogen gas entrained in the discharge region for the case of the argon flow rate of 1SLM compared to that entrained for the argon flow rate of 0.5 SLM case.

#### **b)Visible Region**

Figures 4(a) and 4(b) exhibit emission spectra in the visible portion of the spectrum for argon flow rates of 0.5 SLM and 1.0 SLM, respectively. The N<sub>2</sub> Second Positive System (N<sub>2</sub>[C  ${}^{3}\Pi_{u}$ ]  $\rightarrow$  N<sub>2</sub>[B  ${}^{3}\Pi_{g}$ ]) emission (0,3) band head at 405.94 nm was observed in addition to the second-order (0,0) band at 674.13 nm. Atomic hydrogen lines H<sub>β</sub> and H<sub>α</sub> were observed at 486.13 nm and 656.3 nm

respectively, where  $H_{\beta}$  intensity is much weaker than  $H_{\alpha}$ . The origin of the atomic hydrogen emission might be ascribed to the hydrogen gas in the discharge region because of the dissociation of water vapour which entrained in the discharge region as can be seen from the following reactions [29-34].

 $\begin{array}{l} H_{2}O(Vapor) + h\nu \rightarrow H^{'} + HO^{'} Photodissociation \quad (1) \\ H_{2}O(Vapor) + e \rightarrow OH + H^{-} \quad Dissociative attachment \quad (2) \\ H_{2}O(Vapor) + e \rightarrow OH + H^{+} + 2e \quad Dissociative ionization \quad (: H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \rightarrow OH^{'} + H + e \quad Dissociation of molecule(4) \\ \hline H_{2}O(Vapor) + e \quad D \quad H_{2}O(Vapor) + e \quad D \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad D \quad H_{2}O(Vapor) + E \quad D \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) + E \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad H_{2}O(Vapor) \\ \hline H_{2}O(Vapor) + E \quad H_{2}O(V$ 



**Fig. 3.** Spectra of emission of DCSD in UV region Gap: 3.4 mm; I= 30 mA.

(a) Flowrate 1.0 SLM and accumulation times=30 ms(b) Flowrate 0.5 SLM and accumulation times=30 ms

Several atomic and ionic argon emission lines were also identified, which are belonged to the NIST database [35]. It should be mentioned here that all the emission intensities for the discharge with argon flow rate of 0.5 SLM are stronger than that for the discharge with argon flow rate. 1.0 SLM. This might be attributed to the smaller density of nitrogen gas entrained in the discharge region for the case of the argon flow rate of 1SLM compared to that entrained for the argon flow rate of 0.5 SLM case.

#### c) Near IR Region

The emission spectra of DCSD for argon between 700 and 1000 nm are shown in Figures 5(a) and 4(b) for discharges with argon flow rates of 0.5 SLM and 1.0 SLM, respectively. This region was rich with strong emission atomic argon lines which were listed in table 2. In addition, weak atomic oxygen lines at 777.41 nm and 844.6 nm were observed. It is clearly seen from figures 5(a) & 5(b) that the emission intensity of atomic argon lines in this region for discharge with argon flow rate of 1.0 SLM is stronger than that for discharge with argon flow rate of 0.5 SLM. This might be attributed to the higher excitation temperature of 1.0 SLM flow rate compared with that of 0.5 SLM discharge conditions.



Gap: 3.4 mm; I= 30 mA.

Flowrate 1.0 SLM and accumulation times= 1s Flowrate 0.5 SLM and accumulation times= 2s



**Fig. 5.** Spectra of emission of DCSD Near IR region Gap: 3.4 mm; I= 30 mA.

(a) Flowrate 1.0 SLM and accumulation times=30 ms(b) Flowrate 0.5 SLM and accumulation times= 30ms

## **3.2. Determination of Rotational and Vibrational Temperatures**

The spectra of the  $N_2$  2nd positive system  $N_2$  [B  ${}^3\Pi_g$ ] released in the air are the most useful for plasma diagnostics because they allow for the determination of rotational  $T_r$  and

vibrational  $T_v$  temperatures by comparing experimental and simulated spectra [36]. To measure the rotational ( $T_r$ ) and vibrational ( $T_v$ ) temperatures of the plasma, we employed software created at the Technical University of Eindhoven [26]-[37]. Software is used to model the emission bands of the N<sub>2</sub> 2nd positive system N<sub>2</sub>[B <sup>3</sup>Π<sub>g</sub>] with rotational–vibrational transitions at (0,1), (1,3), and (0,2) from 350 to 385 nm Figure 6 shows an experimental spectrum of N<sub>2</sub> 2nd positive system N<sub>2</sub>[B <sup>3</sup>Π<sub>g</sub>] bands emitted from the DCSD together with the simulated spectrum.



**Fig. 6.** Spectra measured and corresponding best fit modelled spectra Gap: 3.4 mm; I= 30 mA. Flowrate 1.0 SLM

With a correlation of 0. 9975, the best fits of Tr and Tv temperatures were found to be 1087K and 1661K, respectively. The  $T_v$  and  $T_r$  values indicate that the discharge was non-equilibrium.

# **3.3. Electronic Excitation Temperature using Boltzmann Plot Method**

The electronic excitation temperature  $T_{exct}$  is defined by fit a thermal distribution to the properly weighted intensities of a set of atomic and ionic transitions for a specific atomic and ionic species in the discharge. In the case of stabilized atmospheric pressure pin to plate plasma experiment, the atomic and ionic species used are atomic and ionic argon. The emitted atomic and ionic argon species are excited in the discharge and these species will emit spectra when they are de-excited. The

intensity  $I_{ij}$  of Ar I atomic and Ar ionic lines when Ar-atoms are de-excited from an initial excited state i to final state j is given by

$$I_{ij} = C_{ij} \cdot A_{ij} \cdot g_i \cdot v_{ij} \cdot exp\left(\frac{-\epsilon_i}{T_{exct}}\right)$$
(5)

where C is proportionality constant,  $A_{ij}$  is atomic transition probability,  $g_i$  is statistical weight,  $v_{ij}$  is frequency of the atomic or ionic line, and  $\epsilon_i \& T_{exct}$  are the energy of the level i and the excitation temperature in eV, respectively. Rearranging the previous equation, we get the following equation.

$$\frac{I_{ij} \cdot \lambda_{ij}}{A_{ij} \cdot g_i} = C \cdot e_X p \left( \frac{-\epsilon_{exct}}{T_{exct}} \right)$$
(6)

where  $\lambda_{ij}$  is the wavelength of the emitted line. The plot of  $ln(I_{ij}\lambda_{ij}/A_{ij}g_i)$  as a function of  $\epsilon_i$  for each of the selected emitted species, gives points that would be perfectly aligned in case of discharge in local thermal equilibrium (LTE). The slope of this line is  $-1/T_{\text{exct}}$  leading to  $T_{\text{exct}}$ which is a good approximation for Te in the case of LTE. This plot is called Boltzmann plot [38-45]. Each observed Ar atomic line wavelength has an associated energy level  $\epsilon_i$ , a statistical weight  $g_i$ , and atomic transition probability  $A_{ij}$  as given in table 1. In our experiment, we get  $\epsilon_i$ ,  $g_i$ , and  $A_{ij}$  from the NIST Atomic Spectra Database [35].

**Table1**: Spectroscopic parameters of selected Ar emission spectral lines used to estimate plasma temperature using Boltzmann plot method at flowrate 0.5 SLM, 1.0 SLM, I= 30 mA that absorbed between the electrodes

Species	Wavelength (nm)	Aij (s-1)	gk	Ej (eV)
Ar	415.86	1.40E+06	5	14.53
	420.07	9.67E+05	7	14.499
	446.05	1.50E+06	6	19.222
	451.07	1.18E+06	1	14.57
	454.5	4.71E+07	4	19.87
	460.96	7.89E+07	8	21.14
	465.79	8.92E+07	4	19.8
	475.29	4.50E+05	3	15.51
	476.45	6.40E+07	4	19.87
	487.62	7.80E+05	5	15.45
	487.98	8.23E+07	6	19.68
	430.065	5.70E+06	6	21.5
	421.86	3.60E+07	4	22.7
	422.69	4.10E+07	6	24.28
	423.72	1.12E+07	4	21.35



**Fig. 7.** Boltzmann distribution function plot of Ar emission spectral lines

Gap: 3.4 mm; I= 30 mA.

- (a) Flowrate 1.0 SLM and accumulation times=30 ms
- (b) Flowrate 0.5 SLM and accumulation times= 30ms

Figures 7(a) and (b) show Boltzmann plots of argon discharge at flow rates of 0.5 SLM and 1.0 SLM, respectively. According to these results, the electronic excited temperature for discharge with argon flow rates of 0.5 SLM and 1.0 SLM is 1.1 eV and 1.36 eV, respectively. The data shown in figures 7(a) and 7 (b) are fitted by nice straight lines which ensurebthat the plasma in our discharge is followed local thermal equilibrium. The measured electronic excited temperature revealed that the discharge in the current work is strongly non-equilibrium.

#### CONCLUSION

This paper presents the experimental analysis of optical emission spectra for DC atmospheric stabilized plasma source. Identification of the discharge species revealed that the presence of nitrogen second positive system, atomic and ionic argon emission lines, atomic oxygen emission lines and atomic hydrogen emission lines. Rotational and vibrational temperatures were estimated by comparing the measured spectrum of the nitrogen second positive system with the simulated one. Boltzmann plot method was used successfully to determine the electronic excitation temperature. Rotational, vibrational

and electronic excitation temperatures proved that the discharge of the current work is strongly non-equilibrium. The finding of the current work,namelt the non-equilibrium state of the discharge, ensure this plasma source is suitable for material processing applications which is the subject of the forthcoming publications.

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## الملخص العربي الخصائص الطيفية لمصدر بلازما مستقر من ابرة الي لوحة بالضغط الجوي احمد عبدالراضى <sup>(1)</sup>، احمد سمير <sup>(2)</sup>، فاروق الاكشر <sup>(3)</sup>, عبده جارمون <sup>(3)</sup> منصور الصباغ <sup>(2،3)</sup>

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تم الحصول على تفريغ كهربى مستمر ومستقر لغاز ألارجون في الضغط الجوي ما بين ابرة و لوح معدني في هذا البحث ، تم دراسة انهيار غاز الأرجون المتدفق في الهواء كما (مصدر البلازما) بواسطة طريقة التحليل الطيفي للانبعاثات الضوئية. وقد لوحظ أطياف انبعاث الأنواع المثارة من الهيدروجين الذري والنيتروجين الجزيئي والأرجون. وتم قياس درجات الحرارة الدورانية والاهتزازية للتفريغ عن طريق مقارنة محكاة أطياف الانبعاث الضوئي مع القياسات الطيفية من التفريغ وعن طريق استخدام عدة نطاقات اهتزازية مختلفة من النظام الموجب الثاني SPS . وكشفت الخصائص البصرية للتفريغ أن البلازما المتكونة غير متزنة وان درجة حرارة الدورانية تبلغ 1087 كلفن ودرجة حرارة الاهتزازية تبلغ 1661 كلفن. وطُبقت طريقة بولتزمان لتقدير درجة حرارة الإثارة الإلكترونية ووجد أن هي eV 1.36 و eV 1.1 للبلازما المولدة مع معدلات تدفق الأرجون من SLM1.0 و 0.5 SLM على التوالى. وأثبتت هذه النتيجة الطابع الغير متزنة للبلاز ما المتكونة.